





(PTO Form 1449 modified)

APPM/1931.P1

10/052,681..

**SUPPLEMENTAL LIST OF PATENTS AND PUBLICATIONS  
CITED BY APPLICANT**

**Applicant**

**Confirmation No.:**

Xi, et al.

4083

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## OTHER ART

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Initial

**Including Author, Title, Date, Pertinent Pages, Etc.**

AD

C1

K. Min et al., "Comparative Study of Tantalum and Tantalum Nitride as a Diffusion Barrier for CU Metallization" J. Vac. Sc. Technol. B 14(5), Sept/Oct 1996, p 1-7.

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International Search Report for PCT/US01/26751, dated May 27, 2002.

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International Search Report for PCT/US01/24880, dated May 17, 2002.

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International Search Report for PCT/US98/09751, dated September 16, 1998.

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